



S/N 09/825,611

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Sujit Sharan et al.

Examiner: Evan T. Pert

Serial No.: 09/825,611

Group Art Unit: 2826

Filed: April 3, 2001

Docket No.: 303.930US3

Title: METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

**AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This responds to the Office Action mailed on September 16, 2005. Please amend the above-identified patent application as follows.